# Growth of Cr<sub>2</sub>O<sub>3</sub> whiskers by the vapour–liquid–solid mechanism

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When a powder mixture composed of  $Cr_2O_3$ ,  $Al_2O_3$ ,  $SiO_2$  and C was placed on a graphite powder in an alumina crucible with a lid, and the crucible was set in an electric furnace and heated to > 1350 °C,  $Cr_2O_3$  whiskers grew at the surface of the powder mixture. The microstructure in the powder mixture, thermal analysis of the powder mixture during heating, and whisker droplet were investigated. The whiskers were found to have grown by the vapour–liquid–solid (VLS) mechanism.

### 1. Introduction

Ceramic whiskers are grown by vapour or liquid phase reaction. The growth of vapour phase reactions are VLS [1] and VS [2] mechanisms. Morphologically, ceramic whiskers which are grown by the VLS mechanism [2–11] have droplets on their tops, and the whiskers are considered to have grown from them. However, Patrick *et al.* [12] reported that the droplet intercepted the growth of the whisker.

When a powder mixture composed of  $Cr_2O_3$ ,  $Al_2O_3$ ,  $SiO_2$  and C was placed on a graphite powder in an alumina crucible with a lid, and the crucible was heated,  $Cr_2O_3$  whiskers having droplets on their tops grew on the surface of the powder mixture. The effects of starting powder composition, temperature and time on the features of  $Cr_2O_3$  whiskers grown were investigated. The growth mechanism of  $Cr_2O_3$  whiskers was established.

#### 2. Experimental procedure

The starting powder materials were reagent grade  $Cr_2O_3$  (average grain size, 0.5 µm),  $Al_2O_3$  (average grain size, 2.3 µm),  $SiO_2$  ( $\leq 35$  µm) and C (graphite powder). Each of the powder mixtures, with various ratios of  $Cr_2O_3$ ,  $Al_2O_3$ ,  $SiO_2$  (in total, 80 wt %) and C (20 wt %), were placed on graphite powder in an alumina crucible, as shown in Fig. 1a. The crucibles, with lids, were set in an electric furnace and heated at a rate of 600 °C h<sup>-1</sup> at various temperatures for various times.

The growth of whiskers was observed by scanning electron microscopy (SEM), the component was identified by X-ray diffraction (XRD), and a droplet of a whisker was analysed by electron probe microanalysis (EPMA). The amount of solid solubility of  $Al_2O_3$  in  $Cr_2O_3$  was determined as follows. Dense sintered bodies with various compositions of  $Cr_2O_3$  and  $Al_2O_3$  were prepared [13]. A calibration curve between the relative intensity ratio of X-rays in EPMA and the weight fraction for  $Cr_2O_3$  and  $Al_2O_3$  mixing ratio was constructed. The amount of solid solubility of  $Al_2O_3$  in the  $Cr_2O_3$  whisker was determined from this calibration curve.

As shown in Fig. 2, the temperature of the powder mixture during heating was measured by a thermocouple which was set through a hole (measuring  $1 \times 10$  mm) at the centre of the alumina lid into the powder mixture directly. The setting places were at the middle of the powder mixture (point b) and near the graphite powder in the powder mixture (point c) compared with the temperature in the furnace (point a). Moreover, the powder mixture after heating was embedded in epoxy resin and polished. The polished surface was analysed by EPMA.

### 3. Results

### 3.1. Features of the growing whiskers

Fig. 1b shows a schematic drawing of the cross-section of the alumina crucible after heating.  $Cr_2O_3$  whiskers grew on the surface of the powder mixture. Fig. 3 shows the amount of whiskers grown by heating at 1400 °C for 4 h for various original compositions. The maximum amount of whiskers grown was obtained from an original composition of 40 wt %  $Cr_2O_3$ , 20 wt %  $Al_2O_3$ , 20 wt %  $SiO_2$  and 20 wt % C. The composition was selected in the following experiments. Fig. 4 shows SEM photographs of the whiskers grown by heating at 1400 °C for 4 h. They had droplets on their surfaces.

#### 3.2. Analysis of the whiskers

XRD patterns, Fig. 5, show that the grown whiskers were  $Cr_2O_3$  crystals. Fig. 6 shows EPMA photographs of the droplet at the top of the whisker. Si, O and small Cr were detected. Al was detected in the  $Cr_2O_3$  whisker, but not in the droplet. The amount of solid solubility of  $Al_2O_3$  in the  $Cr_2O_3$  whisker was determined at < 1 wt %.



Figure 1 Schematic drawing of the crucible in which  $Cr_2O_3$  whiskers were formed: (a) before heating, and (b) after heating.



*Figure 2* Schematic drawing of temperature measurement of the powder mixture during heating: (a) in the furnace, (b) in the middle of the powder mixture, and (c) near the graphite powder.



Figure 3 The amount of  $Cr_2O_3$  whiskers grown by heating at 1400 °C for 4 h for various original compositions: ( $\odot$ ) large, ( $\bigcirc$ ) small, ( $\bigcirc$ ) none.



Figure 4 SEM photographs of the whiskers grown at 1400 °C for 4 h.

# **3.3.** Effects of temperature and time on the growth of the whiskers

Fig. 7 shows change of average width and length with temperature at 1350-1450 °C for 4 h. On average, length and width of the whiskers grown by heating at 1390 °C for 4 h were about  $1200 \mu m$  and  $6.8 \mu m$ , respectively. Above 1390 °C, the powder mixture, remarkably, became a porous surface, and the amount of whiskers grown decreased. However, the width of the whiskers increased with temperature. Fig. 8 shows the change of average width and length of whiskers with time at 1400 °C. After the whiskers had grown to about 7  $\mu m$  in diameter and 600  $\mu m$  in length, growth seems to have stopped.



*Figure 5* XRD pattern of the grown whiskers: ( $\bullet$ ) Cr<sub>2</sub>O<sub>3(solid)</sub>, ( $\blacktriangle$ ) SiO<sub>2(solid)</sub>.



# 3.4. Behaviour of the powder mixture during heating

Fig. 9 shows the temperatures at points b and c, compared them to that of the furnace at point a in Fig. 2. At points b and c, the rising rate of the temperatures changed at approximately 1370 and 1290 °C, respectively. Fig. 10 shows a cross-section of the powder mixture heated at 1400 °C for a moment. Large pores were formed near the graphite powder. The powder mixture altered to  $Cr_2O_3$ -Al<sub>2</sub>O<sub>3</sub> solid solution (s.s.), SiO<sub>2</sub> (cristobalite), small Cr<sub>2</sub>O<sub>3</sub> and Cr<sub>3</sub>C<sub>2</sub> after heating at 1400 °C for 4 h and was embedded in epoxy resin and polished. Fig. 11 shows EPMA photographs of the polished surface. Since Al, Cr and O were detected at the surface of the powder mixture,  $Cr_2O_3$ -Al<sub>2</sub>O<sub>3</sub> (s.s.) existed, on which  $Cr_2O_3$  whiskers were grown. The same reactants were present in the powder mixture after heating for 1 and 8 h. About 20-32 wt %  $Al_2O_3$  was contained in  $Cr_2O_3$ - $Al_2O_3$  s.s.

### 4. Discussion

## 4.1. Behaviour of the powder mixture during heating

Liquid phase is not formed below  $1575 \,^{\circ}C$  in the  $Al_2O_3-Cr_2O_3-SiO_2$  phase diagram [14]. Since, at





Figure 6 (a) SEM and EPMA photographs of  $K_{\alpha}$  images of (b) Si, (c) Cr, (d) O, and (e) Al for the droplet at the top of a  $Cr_2O_3$  whisker.

≥ 1000 °C, the atmosphere under existing carbon is about 0.1 MPa CO<sub>(gas)</sub> [15], the atmosphere in the alumina crucible with carbon can be considered to be 0.1 MPa CO<sub>(gas)</sub> at ≥ 1000 °C. Fig. 12 shows the relationship between the partial pressures of gaseous species and the stable condensed phases for the partial pressure of CO<sub>(gas)</sub> (log  $p_{CO}$ ) and the partial pressure of O<sub>2(gas)</sub> (log  $p_{O2}$ ) in the system Si–Cr–Al–C–O at 1427 °C (1700 K) on the basis of JANA thermodynamics-data [16]. As an example, Cr<sub>2</sub>O<sub>3</sub> is not a stable condensed phase at  $-1 = \log p_{CO}$ . At  $p_{CO}$ , vaporization of the oxides increased and the liquid phase can be generated at relatively lower temperature [17]. In fact, changes of rising rate of temperatures at



Figure 7 Changes of average length ( $\bullet$ ) and width ( $\bigcirc$ ) of Cr<sub>2</sub>O<sub>3</sub> whiskers with temperature after 4 h.



Figure 8 Changes of average length ( $\bullet$ ) and width ( $\bigcirc$ ) of Cr<sub>2</sub>O<sub>3</sub> whiskers with time at 1400 °C.



Figure 9 Changes of temperatures in the powder mixture under conditions of a constant heating rate of  $600 \,^{\circ}$ Ch<sup>-1</sup>: (a) in the electric furnace, (b) in the middle of the powder mixture, and (c) in the powder mixture near the graphite powder.

about 1290 and  $1370 \,^{\circ}$ C as shown, in Fig. 9, are considered to be responsible for the formation of the liquid phase.

As shown in Fig. 10, some large pores which are found near the graphite powder are due to be formed by generation of  $CO_{(gas)}$  on the basis of Equation 1.

$$3Cr_2O_{3 \text{ (solid)}} + 13C_{\text{(solid)}} = 2Cr_3C_{2 \text{ (solid)}} + 9CO_{\text{(gas)}}$$
(1)

Since a log  $p_{CO}$ , on the basis of Equation 1 at 1427 °C, is calculated at 0.66 ( $p_{CO} = 4.60$  MPa) and the value is 46 times as large as atmospheric pressure,  $CO_{(gas)}$  comes to be continuously exhausted out of the powder mixture during heating.

Other gaseous species generated from the powder mixture during heating can be considered as follows. Log  $p_{CO}$  in the powder mixture at 1427 °C seems to always change at -1-0.66, at which  $Cr_2O_3$  can condense, in Fig. 12. Then, log  $p_{SiO}$  is the highest among the gaseous species in Si–O system and the value is -4.28 (point a in Fig. 12) to -5.95 (point b). Log  $p_{Cr}$  is the highest value among the gaseous species in the Cr–O



Figure 10 Cross-section of the powder mixture heated at  $1400 \,^{\circ}$ C for a moment.

system and the value is -6.79 (point c-d). On the other hand, log  $p_{A1}$  which is the highest in the Al–O system is about a third to a sixth of log  $p_{Cr}$ ; in effect, negligible. After all, SiO<sub>(gas)</sub> and Cr<sub>(gas)</sub> are mainly exhausted from the powder mixture. A schematic drawing, Fig. 13a, shows the supplying process of the gaseous species from the powder mixture.

### 4.2. Growth mechanism of Cr<sub>2</sub>O<sub>3</sub> whiskers

 $Cr_2O_3$  whiskers are considered to be grown by the VLS mechanism because of the presence of droplets on the whisker surface, as shown in Fig. 4. Since Si, O and small Cr are detected at the droplet, as shown in Fig. 6, the droplet is reflected to be Si-Cr-O liquid during heating. That is, the liquid is developed by the formation of  $SiO_{2-x}$ -Cr<sub>2</sub>O<sub>3-y</sub> at lower  $p_{O_2}$ . SiO<sub>(gas)</sub> and Cr(gas) carry out efficiently to the surface of the powder mixture with exhausting CO<sub>(gas)</sub>, and condense as a liquid of Si–Cr–O. SiO<sub>(gas)</sub> and Cr<sub>(gas)</sub> further dissolve in the liquid. The supersaturation of  $Cr_2O_3$  which is caused by dissolving  $O_{2 \text{ (gas)}}$ , precipitates  $Cr_2O_3$  crystals at the bottom of the liquid. The process is repeated to form the whisker with a droplet on its top. Fig. 13b shows a schematic drawing of the Cr<sub>2</sub>O<sub>3</sub> whisker grown by the VLS mechanism in this study.

When the powder mixture composed of  $Cr_2O_3$ , SiO<sub>2</sub>, and C was used,  $Cr_2O_3$  whiskers did not grow. It is considered that  $Al_2O_3$  decreases the melting point of the powder mixture and accelerates the occurrence of the liquid phase. Therefore,  $p_{CO}$  is higher in the powder mixture and the exhausting  $CO_{(gas)}$  then accelerates the supplying of SiO<sub>(gas)</sub> and  $Cr_{(gas)}$  for the growth of  $Cr_2O_3$ whiskers at lower temperatures.

# 4.3. Effect of temperature and time on the growth of Cr<sub>2</sub>O<sub>3</sub> whiskers

The lengths of  $Cr_2O_3$  whiskers decrease with temperature after showing a maximum value around 1390 °C as shown in Fig. 7. Fig. 14 shows the equilibrium partial pressures of  $SiO_{(gas)}$  and  $Cr_{(gas)}$  under the existence of  $(SiO_2 + C)$  and  $(Cr_3C_2 + C)$  at 0.1 MPa  $CO_{(gas)}$ , respectively. At about 1390 °C, the values of  $p_{SiO}$  and  $p_{Cr}$ may be suitable for the growth of whiskers. Since the



Figure 11 (a) SEM and EPMA photographs of  $K_{\alpha}$  images of (b) Cr, (c) Al, (d) Si and (e) O near the surface of the powder mixture. Arrow points to surface of the powder mixture.

 $200 \, \mu m$ 

tion of  $SiO_2$  from the droplet occurs, remarkably, to stop the growth of the whisker.

### 5. Conclusions

A powder mixture composed of  $Cr_2O_3$ ,  $Al_2O_3$ ,  $SiO_2$ and C was placed onto a graphite powder in an alumina crucible with a lid. When the crucible was heated in an electric furnace,  $Cr_2O_3$  whiskers with droplets on the tops were grown on the surface of the powder mixture. The growth mechanism of the whiskers was investigated and the following results obtained.

1. Si–Cr–O liquid in the powder mixture is formed at > 1290 °C. SiO<sub>(gas)</sub> and Cr<sub>(gas)</sub> are mainly supplied by exhausting CO<sub>(gas)</sub> which is generated by reaction of Cr<sub>2</sub>O<sub>3</sub> and C.

2.  $Cr_2O_3$  whiskers are grown by the VLS mechanism. The whisker is grown from a droplet that is generated by condensation of  $SiO_{(gas)}$  and  $Cr_{(gas)}$  and is a liquid of Si–Cr–O at growing temperatures.

3. The average width and length of the whiskers grown by heating the powder mixture composed of  $40 \text{ wt }\% \text{ Cr}_2\text{O}_3$ ,  $20 \text{ wt }\% \text{ Al}_2\text{O}_3$ ,  $20 \text{ wt }\% \text{ SiO}_2$  and

rate of increase of log  $p_{\rm SiO}$  is larger than that of log  $p_{\rm Cr}$  with temperature, the SiO<sub>2</sub>/Cr<sub>2</sub>O<sub>3</sub> ratio in the droplet is considered to increase. As a result, SiO<sub>2</sub> can precipitate from the droplet to intercept the growth in the elongated direction of the whisker. On the other hand, the growth in width of the whiskers with temperature is due to the VS mechanism [2] acting at the lateral surfaces of the whiskers. At > 1450 °C, the precipita-



Figure 12 Relationship between the partial pressures of gaseous species and stable condensed phases for  $\log p_{O_2}$  and  $\log p_{CO}$  in the system Si-Cr-Al-C-O at 1427 °C. Points a and b show the  $\log p_{SiO}$  at -1 and 0.66 =  $\log p_{CO}$ , respectively. Points c and d show the  $\log p_{Cr}$  at -1 and 0.66 =  $\log p_{CO}$ , respectively. No marked two points show the  $\log p_{A1}$  at -1 and 0.66 =  $\log p_{CO}$ .



*Figure 13* Schematic drawing explaining growth mechanism of  $Cr_2O_3$  whiskers: (a) gaseous species exhausting from the powder mixture during heating, and (b) VLS mechanism of a  $Cr_2O_3$  whisker.

20 wt % C at 1390 °C for 4 h are about 6.8 and 1200  $\mu$ m, respectively. The width of the whiskers is increased and the length decreased with temperature at above 1390 °C. The whiskers are not grown above 1450 °C.



*Figure 14* Equilibrium partial pressures of SiO<sub>(gas)</sub> and Cr<sub>(gas)</sub> under existence (SiO<sub>2</sub>–C) and (Cr<sub>3</sub>C<sub>2</sub>–C) at 0.1 MPa CO<sub>(gas)</sub>, respectively.

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Received 15 February and accepted 17 July 1995